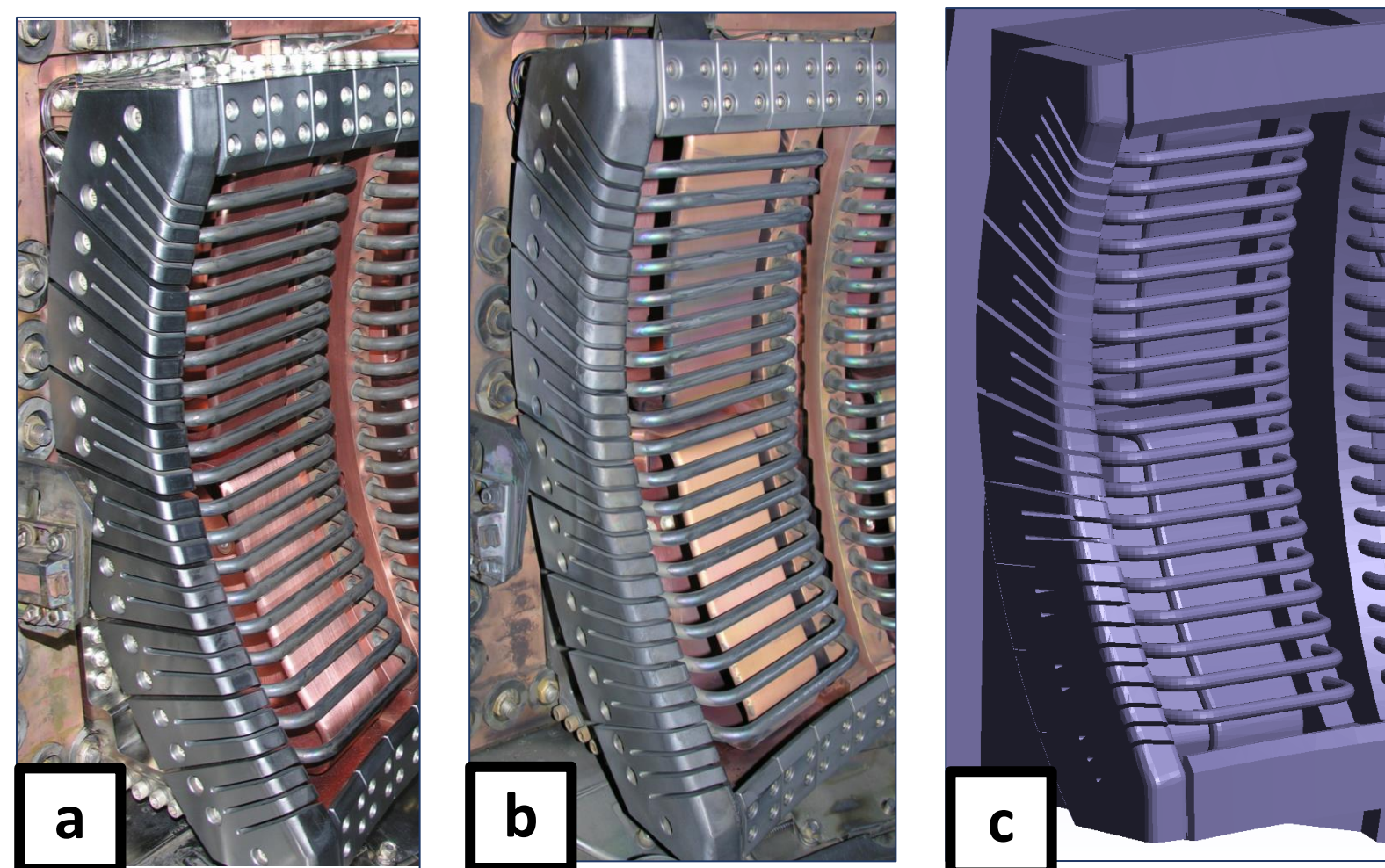


## Motivation

Impurities coming from the tokamak walls during ICRH antenna heating operation can contaminate the fusion plasma and cause:

- 1) Radiation power losses
- 2) Disruptions
- 3) Damage of the PFC

Understanding the physics of the plasma conditions in which the impurities get released has a crucial role in the healthy operation of a tokamak.



**Figure 1.** (a) ICRH antenna on C-Mod before plasma operations (b) ICRH antenna after plasma exposure; (c) CAD model [1].

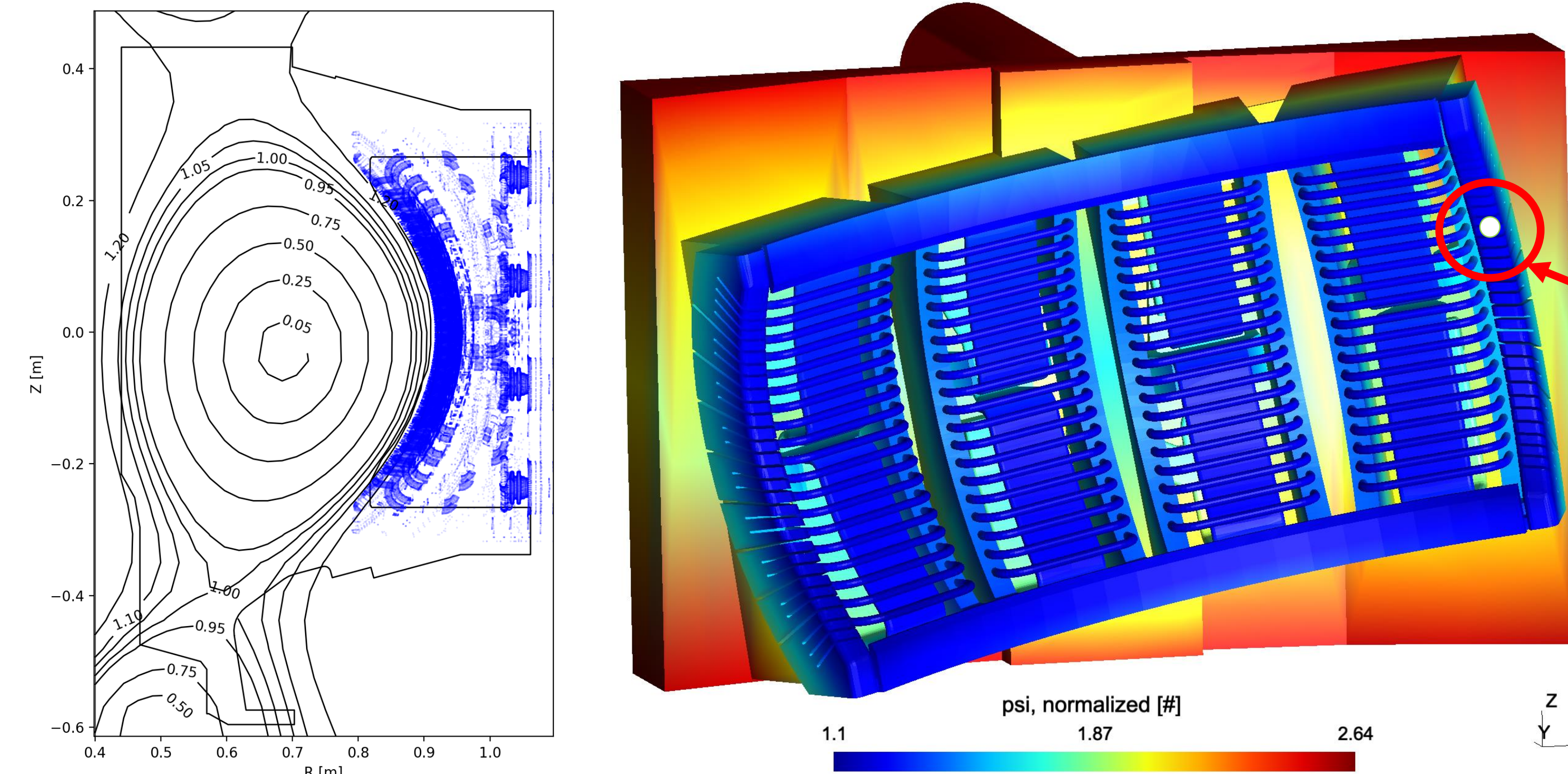
## Summary

- We calculated the nonlinear RF sheath boundary conditions using the STIX electromagnetic solver.
- Using the output from STIX code [2], we produced numerical simulations of the wall impurity flux produced during ICRH operations in Alcator C-Mod using the hPIC2 Particle-in-Cell code [3] and RustBCA ion-surface interaction code [4].
- We analyzed a deuterium plasma impacting on a Mo covered RF limiters surrounding the ICRH launcher at different levels of plasma contamination (Mo atomic concentration 0-5%).

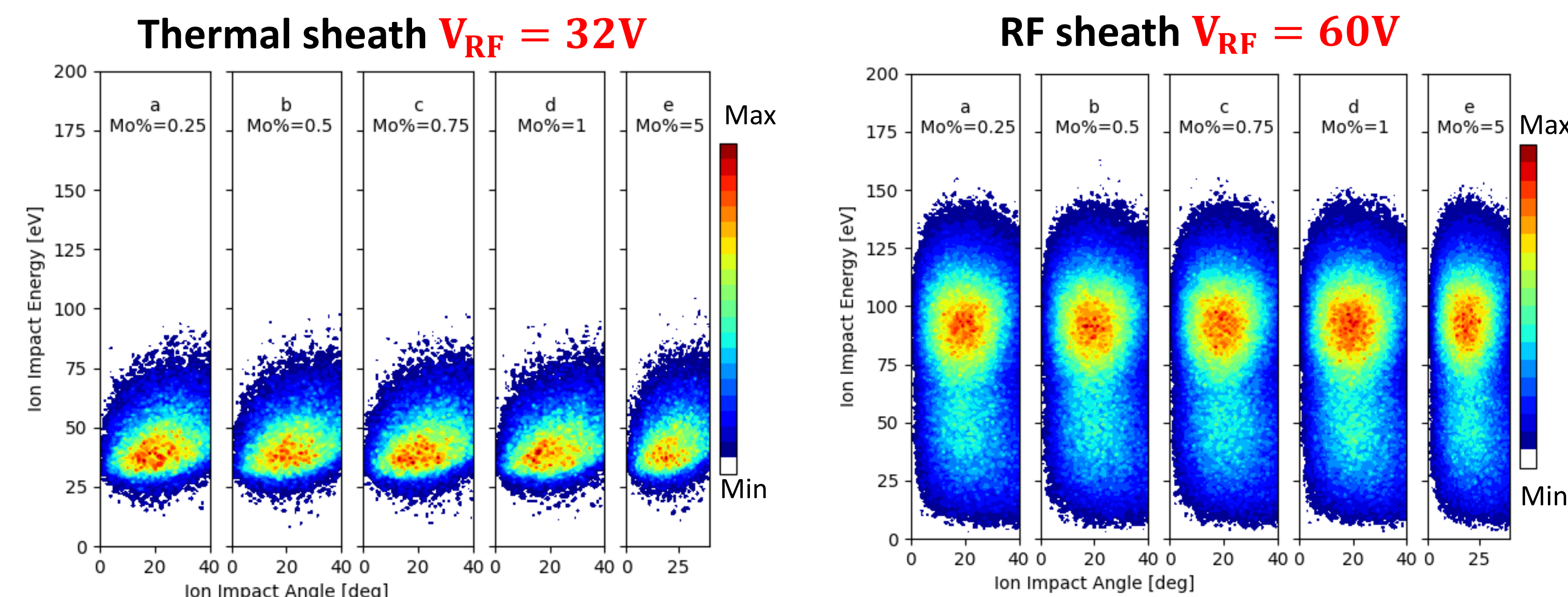
## Conclusions

- 1) An increase of the impurity flux was determined from the hPIC2 code where the RF biasing caused a broadening of the ion energy distribution function (IED) due to the RF sheath.
- 2) Enhancement of Mo erosion flux as a function of the antenna strap phasing conditions also observed in the experiments.
- 3) **Next Steps:** Effects related to impurity charge distribution obtained from ionization balances are expected to modify the erosion fluxes significantly, and they will have to be considered.

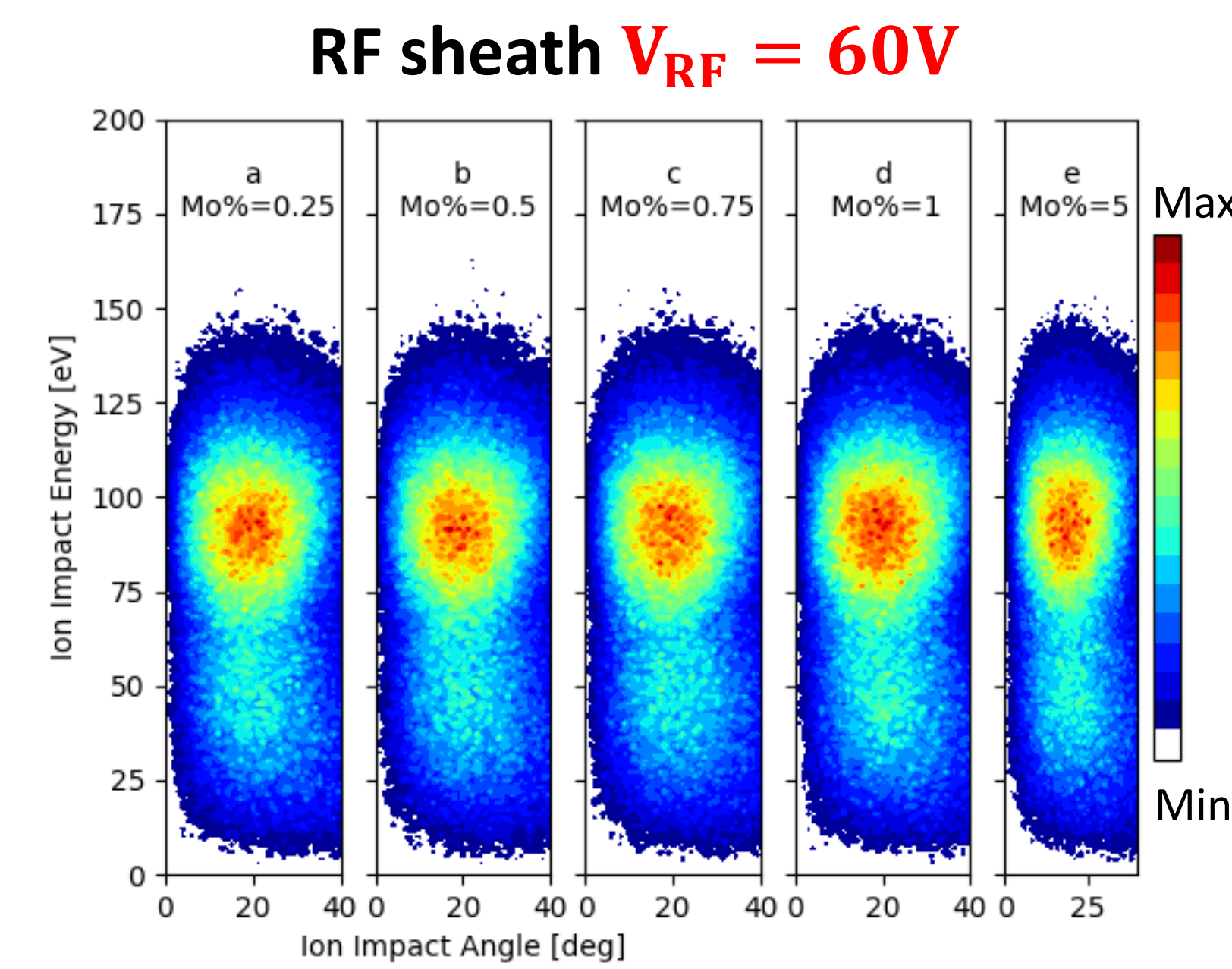
## Magnetic Equilibrium and Antenna Location



## Step 1. hPIC2 – IEAD – Ion Energy Angle Distributions



**Figure 2.** IEADs with one-peak energy structure of a thermal sheath centered at 37.5 eV and impact angles  $\theta \approx 20$



**Figure 3.** IEADs with typical two-peak energy structure of RF sheaths (RF peak at 90 eV). A high concentration of ions centered at impact angles  $\theta \approx 20$  is observed.

## Scan over Impurity Concentration

- D, main plasma species
- Two impurities assumed:
  - O as low-Z impurity
  - Mo as high-Z impurity

- Mo and O ranges are assumed in a range from 0.25-5.0% (atomic %)
- Furthermore, we assumed all impurities with unitary charge  $Z=1$

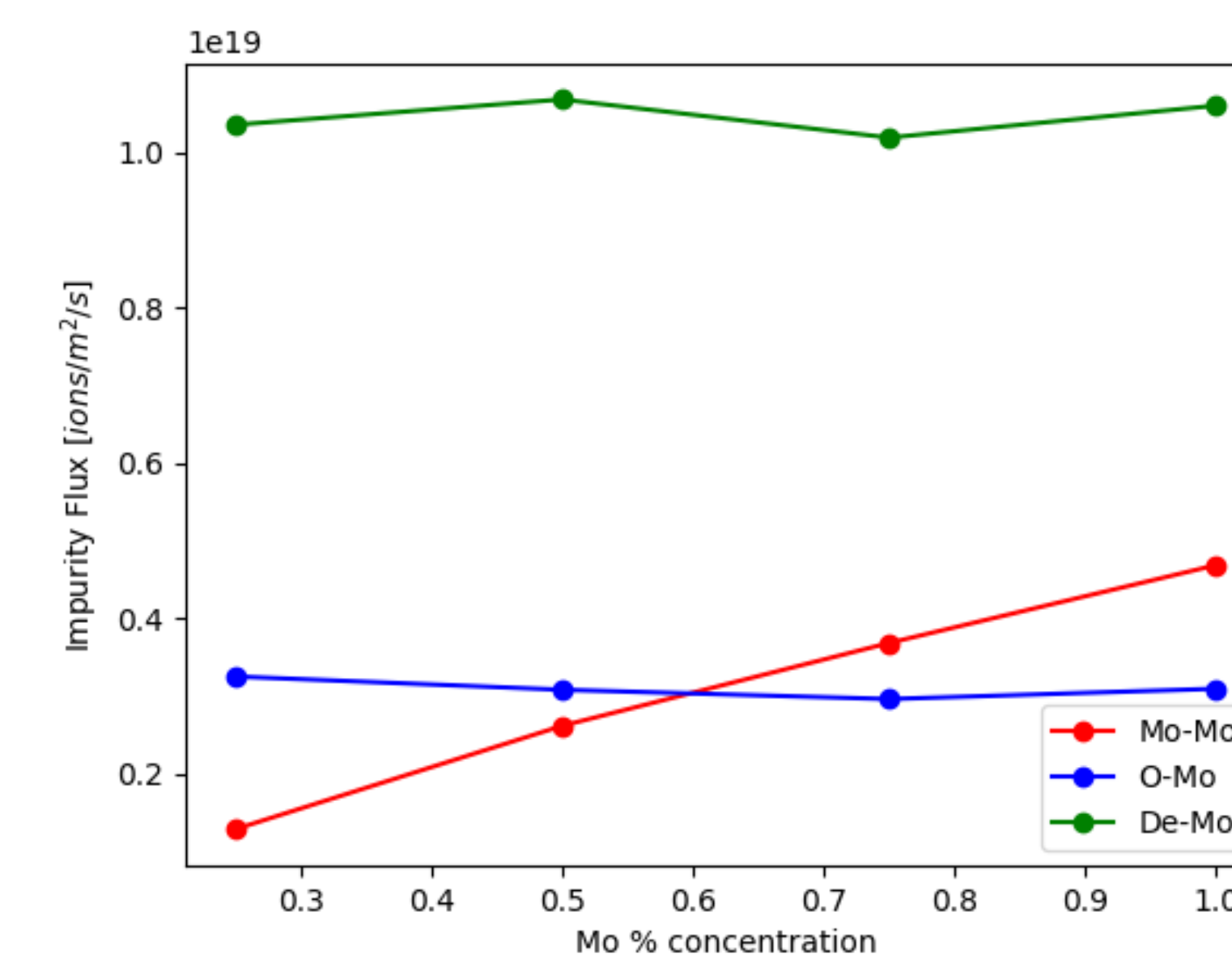
| Scenarios | D % (Z=1) | Mo % (Z=1) | O % (Z=1) |
|-----------|-----------|------------|-----------|
| a         | 98.75     | 0.25       | 1         |
| b         | 98.5      | 0.5        | 1         |
| c         | 98.25     | 0.75       | 1         |
| d         | 98        | 1          | 1         |
| e         | 94        | 5          | 1         |

Location on the region of interest from the STIX simulations (0.39, 0.84, 0.15) m

## Step 3. Erosion fluxes vs. Impurity Concentration

RF - OFF

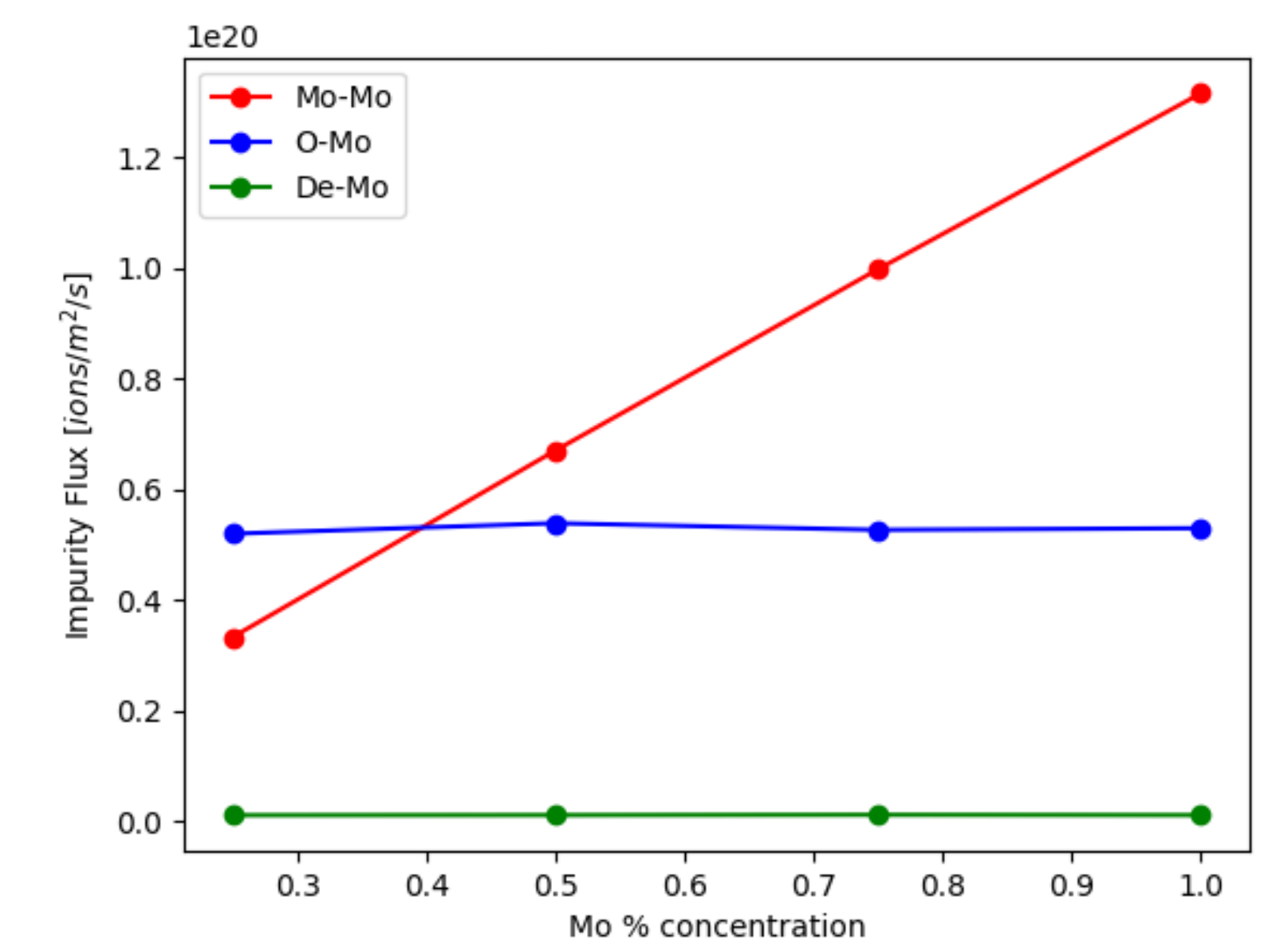
Thermal sheath  $V_{RF} = 32V$ , IEAD peak at 37.5 eV



**Figure 4.** Impurity fluxes of Mo (red), O (blue) and De (green) in the thermal sheath formed at 32 V as a function of the Mo concentration. The impurity fluxes of low-z ions are non-negligible and higher than high-z impurities in the conditions of a thermal sheath.

RF - ON

RF sheath  $V_{RF} = 60V$ , IEAD RF peak at 90 eV



**Figure 5.** Impurity fluxes of Mo (red), O (blue) and De (green) as a function of the Mo concentration in an RF sheath formed at a rectified voltage of 60V. The impurities level is increased by an approximately a factor of 10 compared to the RF-OFF case.

## Workflow

STIX

Inputs:

$\Psi$ : Magnetic equilibrium data

Outputs:

$V_{RF}$ : rectified voltage

$B$ : magnetic field

$E$ : electric field

hPIC2

$$\frac{\partial f_s}{\partial t} + \vec{v} \cdot \nabla f_s + \frac{e}{m} (\vec{E} + \vec{v} \times \vec{B}) \cdot \nabla_{\vec{v}} f_s = 0$$

$$\frac{d^2 \phi}{dx^2} = -\frac{e}{\epsilon_0} (Z_s n_s - n_e)$$

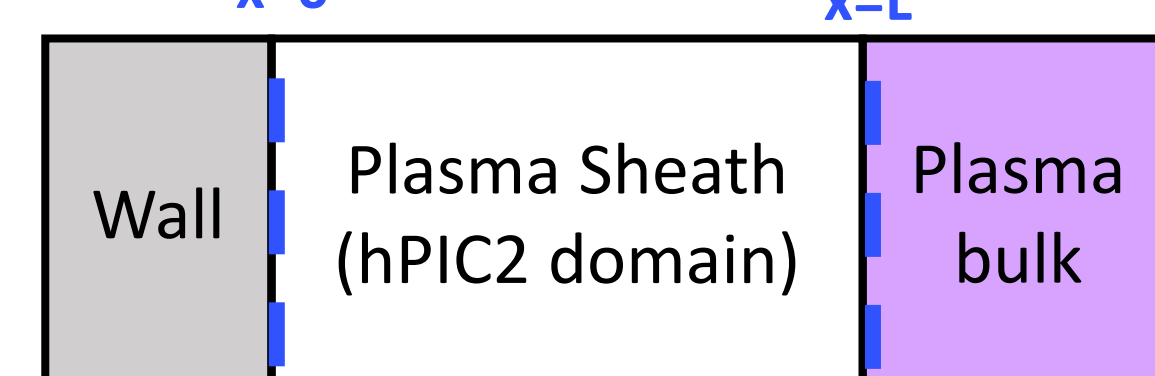
Where  $s = D, O, Mo$

- **Boundary conditions:**

$$\phi(x=0, t) = V_{RF} \sin(\omega t) - V_{DC}$$

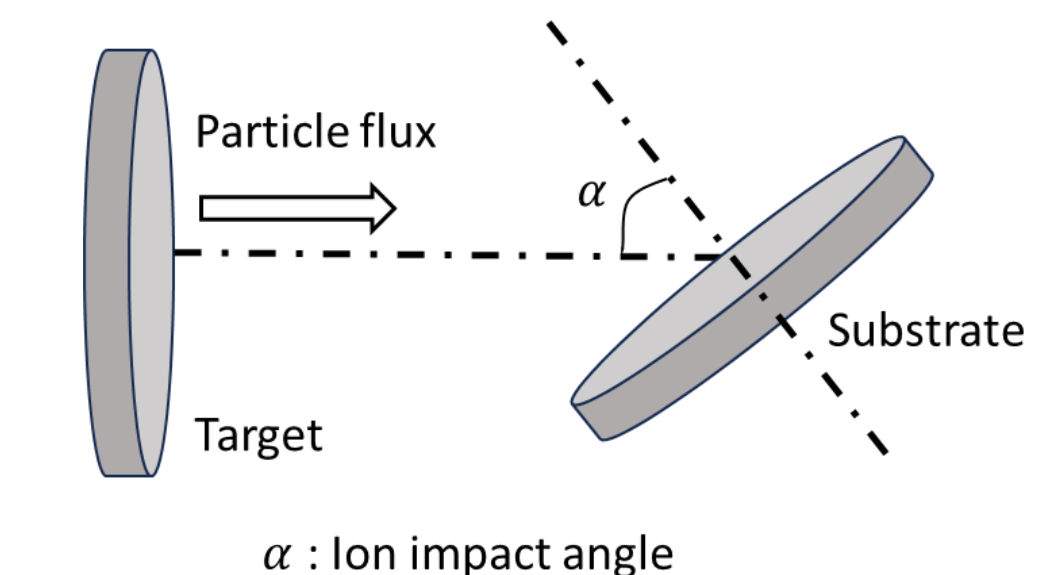
$$\frac{d\phi}{dx}(x=L, t) = 0$$

West boundary  $x=0$  East boundary  $x=L$



RustBCA

$$\bar{Y} = \iint Y(E_i, \theta_i) \hat{f}_i(E_i, \theta_i) dE_i d\theta_i$$

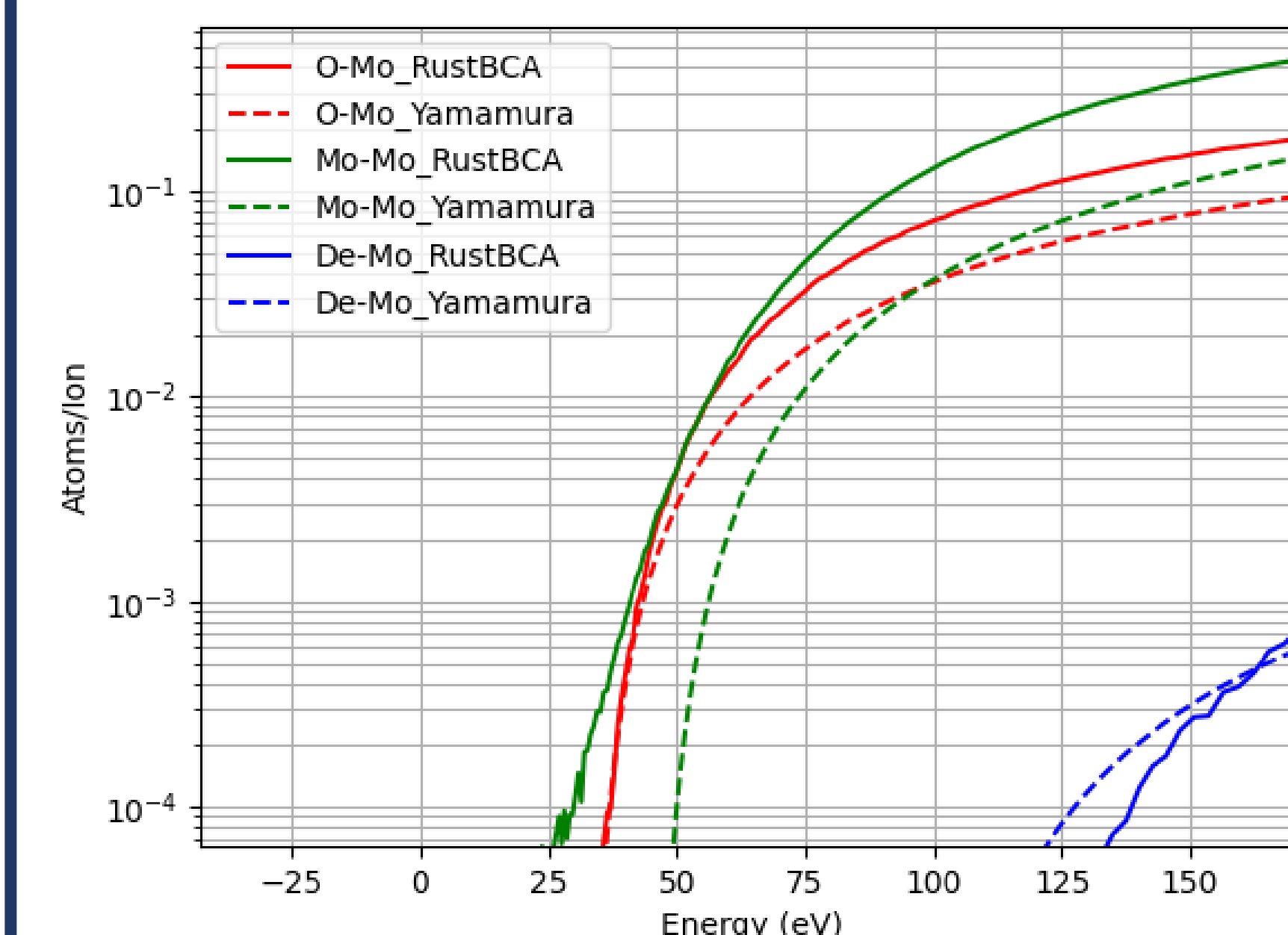


|                  |           |
|------------------|-----------|
| Ion impact angle | 20°       |
| Energy domain    | 10-200 eV |

Erosion flux

$$\Gamma_s = \Gamma_i \bar{Y}$$

## Step 2. RustBCA – Sputtering Yi



**Figure 6.** Maximum sputtering yield profiles of O-Mo, Mo-Mo and De-Mo calculated with RustBCA at 0 eV bulk binding energy (solid lines) in comparison to the empirical calculation using the Yamamura equation (dotted lines).

## References

1. PSFC-MIT. Available in: <https://www-internal.psfc.mit.edu/research/alcator/photos/NVESSEL/2015/Close%20up%20Survey%203-3-16/>
2. Migliore C. et al 2023 Development of impedance sheath boundary condition in Stix finite element RF code (arXiv:2306.12930)
3. L.T. Meredith, M. Rezazadeh, M.F. Huq, J. Drobny, V.V. Srinivasaragavan, O. Sahni, and D. Curreli. hpic2: A hardware-accelerated, hybrid particle-in-cell code for dynamic plasma-material interactions. Computer Physics Communications, 283:108569, 2023.
4. J.T. Drobny, D. Curreli. J. Open Sour. Softw., 6 (64) (2021), p. 3298, 10.21105/joss.03298

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